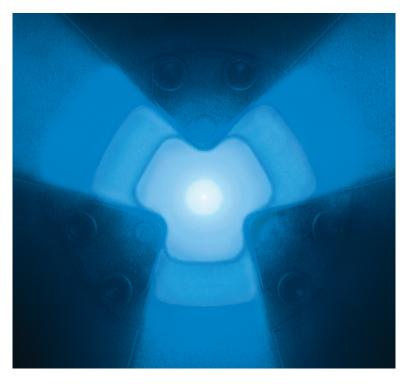
# EQ-10R

# Compact, Reliable, Electrodeless Z-Pinch™ 10 Watt EUV Source

#### Overview

The EQ-10R is a compact, easy-to-use, reliable, and cost-effective light source, based on Energetiq's proven Electrodeless Z-Pinch™ technology using Xenon gas. The EQ-10R EUV source is uniquely suited for metrology and research applications. With over 30 delivered and installed around the world, the EQ-10R series have become the workhorse EUV sources for the EUV community through their proven reliability, ease of use, and low operating cost.

The Energetiq EQ-10R EUV Source's modular design makes it ready to be integrated in a process tool. The system includes the Electrodeless Z-Pinch  $^{\text{TM}}$  source assembly, vacuum and gas subsystems, power delivery subsystem, and control electronics. The EQ-10R is capable of delivering up to 10 Watts of in-band EUV into 2  $\pi$  steradians and will run continuously at pulse repetition rates of up to 2 kHz.



Electrodeless Z-Pinch™ Souce – View of visible light



# **Typical Performance**

10 W into 2 π using Xenon
Up to 2 kHz pulse rate
500 μm
Low debris

# **Cost of Ownership**

Low Xenon flow rate	
Minimized consumable cost	
Small footprint	
Minimized downtime	

### **Proven Reliability**

Patented Electrodeless Z-Pinch™ technology	
CE Mark and SEMI S2-0715 compliant	

# **Applications**

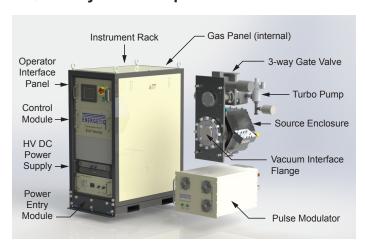
EUV Metrology
EUV Resist Development
Defect Inspection
EUV Microscopy

#### **Electrodeless Z-Pinch™ Technology**

Z-pinch plasmas have been shown to be effective at producing EUV and SXR light. However, all the implementations to date have involved conducting high discharge currents into the plasma using electrodes. These electrodes, which are typically in contact with high temperature plasma, can melt and produce significant debris.

Energetiq's unique technology is also based on a Z-pinch plasma, however it avoids electrodes entirely by inductively coupling the current into the plasma. The plasma in the Energetiq source is magnetically confined away from the source walls, minimizing the heat load and reducing debris. Energetiq's Electrodeless Z-Pinch™ technology has excellent spatial stability and stable repeatable power output.

#### **EQ-10R System Components**



#### **Specifications**

EUV Power Output	20 Watts into 2π steradians (13.5 nm, ±1% bandwidth)
Pulse Repetition Rate	1200 to 2500 Hz
Source Operating Pressure	70 to 150 mTorr typical
Xenon Flow Rate	5 to 15 sccm typical

#### **Physical Specifications**

Component	Dimensions (H x W x D)	Weight
Instrument Rack	1356 x 611 x 915 mm	215.5 kg
Modulator	498 x 356 x 701 mm	54.4 kg
Source	764 x 556 x 533 mm	95.3 kg
Fore Pump Assembly	643 x 259 x 460 mm	27.7 kg

#### **Utility Requirements**

Electrical	200–230V, 3Ø, 50/60 Hz, 30A
Cooling Water	40-60 PSIG (0.28–0.41 MPa), 9.5 lpm, 30°C max. inlet
Clean Dry Air	75–90 PSIG (0.52–0.62 MPa)
Xenon	15–40 PSIG (0.10–0.28 MPa), 20 sccm max. (10 sccm typ.)

#### Compliance

EQ-10R Series	CE Mark, SEMI S2-0715
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